Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/600,151	HAAPALAHTI ET AL.	
Examiner	Art Unit	
Paul D. Kim	3729	

SEARCHED					
Class	Subclass	Date	Examiner		
29	594 731 753 754 761 443	10/28/2005	PK		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Text Search EAST/NPL (IEEE)	10/28/2005	PK	
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